



04-21-06

ITW

AMENDMENT TRANSMITTAL LETTER			Docket No. 108298718US		
Application No. 10/733,523-Conf. #9060	Filing Date December 10, 2003	Examiner D. P. Turocy	Art Unit 1762		
Applicant(s): Beaman et al.					
Invention: METHODS AND SYSTEMS FOR CONTROLLING TEMPERATURE DURING MICROFEATURE WORKPIECE PROCESSING, E.G., CVD DEPOSITION					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	27	- 41 =		x	
Independent Claims	4	- 6 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0665</u> as described below.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Chen Liang Attorney/Agent Reg. No.: 51,945			Dated: <u>April 20, 2006</u>		
PERKINS COIE LLP P.O. Box 1247 Seattle, Washington 98111-1247 (206) 359-8000					



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: KEVIN L. BEAMAN ET AL.
APPLICATION NO.: 10/733,523
FILED: DECEMBER 10, 2003
FOR: **METHODS AND SYSTEMS FOR
CONTROLLING TEMPERATURE
DURING MICROFEATURE
WORKPIECE PROCESSING, E.G., CVD
DEPOSITION**

EXAMINER: DAVID P. TUROCY
ART UNIT: 1762
CONF. NO: 9060

Amendment Under 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated January 20, 2006 in the above-identified application. Please amend the application as reflected in the following list of claims.